IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: ARONOWITZ et al. Attorney Docket No.: 02-5804/LSI1P212

Application No.: 10/697,506 Examiner: Bret P. Chen

Filed: November 29, 2003 Group: 1762

Title: VAPORIZATION AND HANDLING OF

METALS FOR USED IN SEMICONDUCTOR

PROCESSING

Confirmation No.: 8055

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Alexandria, VA 22313-1450 on July 13, 2007.

Signed: /swx/

Susan W. Xu

AMENDMENT D

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Examiner:

This Amendment is in response to the Office Action dated May 31, 2007. It is respectfully requested that the above-referenced patent application be reconsidered in light of the remarks made herein below. The applicants kindly request that the Examiner allow the aboveentitled application as set forth below:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.